## (19) World Intellectual Property Organization

International Bureau





(43) International Publication Date 15 April 2004 (15.04.2004)

**PCT** 

## (10) International Publication Number WO 2004/030612 A3

(51) International Patent Classification<sup>7</sup>: 31/12, 33/00

H01L 27/25,

(21) International Application Number:

PCT/US2003/027547

(22) International Filing Date:

3 September 2003 (03.09.2003)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data:

0210868

3 September 2002 (03.09.2002) FR

(71) Applicant: CORNING INCORPORATED [US/US]; 1 Riverfront Plaza, Corning, NY 14831 (US).

(72) Inventors: DAHMANI, Brahim; 5 bis, rue Gabriel Peri,

rue Grande, F-77250 Villecerf (FR).

F-F-92120 Montrouge (FR). GUZMAN, Guillaume; 56

(74) Agent: BEALL, Thomas R; Corning Incorporated, SP TI 3 1, Corning, NY 14831 (US).

(81) Designated States (national): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NI, NO, NZ, OM, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, TJ, TM, TN, TR, TT, TZ, UA, UG, UZ, VC, VN, YU, ZA, ZM, ZW.

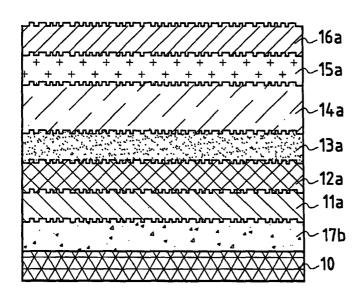
(84) Designated States (regional): European patent (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PT, SE, SI, SK, TR).

## **Published:**

- with international search report
- before the expiration of the time limit for amending the claims and to be republished in the event of receipt of amendments
- (88) Date of publication of the international search report: 14 April 2005

For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.

(54) Title: LIGHT EMITTING DIODE, SUPPORT & METHOD OF MANUFACTURE



(57) Abstract: A light emitting diode of the stacked-layer structure type, incorporating at least one layer made of an inorganic material between the layer forming the substrate (10) and a layer forming the light emitting layer (14), is provided, in which a periodic structure at the wavelength range emitted by the light emitting layer is printed. Also described is a method for generating a microstructure periodic with a wavelength range of the emitting layer of a light emitting diode. The method includes: depositing an inorganic material layer by a sol-gel process between the substrate and a light emitting layer, and printing the periodic structure onto the outer surface of this layer by soft lithography, as well as using this process for manufacturing a light emitting diode.

## INTERNATIONAL SEARCH REPORT

International application No.

PCT/US03/27547

A. CLASSIFICATION OF SUBJECT MATTER  IPC(7) : H01L 27/25, 31/12, 33/00			
US CL : 257/79			
According to International Patent Classification (IPC) or to both national classification and IPC			
B. FIELDS SEARCHED			
Minimum documentation searched (classification system followed by classification symbols) U.S.: 257/79			
Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched			
Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) PLUS, EAST			
C. DOCUMENTS CONSIDERED TO BE RELEVANT			
Category *	cory * Citation of document, with indication, where appropriate, of the relevant passages		Relevant to claim No.
Y, E	US 2004/0156982 A1 (MARUYAMA et al) 12 Aug	ust 2004 (12.08.2004), paragraphs 23-	1-22
Y, P	3O. US 6,512,249 B2 (KOYAMA et al) 28 January 2003 (28.01.2003), column 3 lines 40-47.		1-22
Y, P	US 6,512,250 B1 (KOYAMA et al) 28 January 2003, column 5 lirnes 10-55.		1-22
Fuethor	do comments are listed in the continuation of Pay C	Con natant family array	
Further documents are listed in the continuation of Box C.  See patent family annex.  * Special categories of cited documents: "T" later document published after the international filing date or priori			motional Clina data as mississ
"A" document	defining the general state of the art which is not considered to be	date and not in conflict with the applic	ation but cited to understand the
"E" earlier ap	plication or patent published on or after the international filing date	"X" document of particular relevance; the considered novel or cannot be conside when the document is taken alone	
establish t specified)	which may throw doubts on priority claim(s) or which is cited to he publication date of another citation or other special reason (as	"Y" document of particular relevance; the considered to involve an inventive step combined with one or more other such	when the document is documents, such combination
"O" document	referring to an oral disclosure, use, exhibition or other means	being obvious to a person skilled in the	e art
"P" document published prior to the international filing date but later than the priority date claimed		"&" document member of the same patent family	
		Date of mailing of the international search	ch rep@8 FEB ZUU5
	2004 (30.09.2004)	Authorized officer	-
Name and mailing address of the ISA/US  Mail Stop PCT, Attn: ISA/US  Commissioner for Patents  P.O. Box 1450  Alexandria, Virginia 22313-1450  Facsimile No. (703) 305-3230		Authorized officer  Amir Zarabian  Janua R. Matthews  Telephone No. 571-272-1852	

Form PCT/ISA/21O (second sheet) (July 1998)